



UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2829  
Examiner: J. Hollington

In Re PATENT APPLICATION Of:

Applicant: Mikio OHTAKI

Appln. No.: 09/904,663

Filed: July 16, 2001

For: METHOD FOR MANUFACTURING  
AND BATCH TESTING  
SEMICONDUCTOR DEVICES

Atty Ref.: KAN 120D1

AMENDMENT

July 13, 2004

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

This Amendment is filed in response to the Office Action dated April 13, 2004, the time for response to which is up to and including July 13, 2004. Please amend the above-referenced application as shown on the following pages.

**Certification Under 37 C.F.R. §1.8 (if applicable)**

I hereby certify that this Amendment is being deposited with the United States Postal Service as First Class Mail under 37 C.F.R. §1.8 on this July 13, 2004 and addressed to the Commissioner of Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450.

**Phillip G. Avruch**

Typed or printed name of person mailing the Amendment

Signature of person mailing the Amendment